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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Kazuhiko ITAYA, et al.

SERIAL NO.: NEW U.S. PCT APPLICATION

FILED: HEREWITH

INTERNATIONAL APPLICATION NO.: PCT/JP06/307155

INTERNATIONAL FILING DATE: March 29, 2006

FOR: THIN FILM PIEZOELECTRIC RESONATOR AND METHOD OF MANUFACTURING  
THE SAME

**REQUEST FOR PRIORITY UNDER 35 U.S.C. 119**  
**AND THE INTERNATIONAL CONVENTION**

Commissioner for Patents  
Alexandria, Virginia 22313

Sir:

In the matter of the above-identified application for patent, notice is hereby given that the applicant claims as priority:

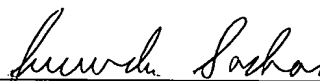
**COUNTRY**  
Japan

**APPLICATION NO**  
2005-229815

**DAY/MONTH/YEAR**  
08 August 2005

Certified copies of the corresponding Convention application(s) were submitted to the International Bureau in PCT Application No. PCT/JP06/307155.

Respectfully submitted,  
OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, P.C.



Marvin J. Spivak  
Attorney of Record  
Registration No. 24,913  
Surinder Sachar  
Registration No. 34,423

Customer Number  
**22850**

(703) 413-3000  
Fax No. (703) 413-2220  
(OSMMN 08/03)